

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

KUME et al.

Application No. Unassigned

Filed: March 11, 2004

Art Unit: Unassigned

Examiner: Unassigned

For: ULTRAVIOLET LIGHT RADIATING
APPARATUS, WET ETCHING
APPARATUS AND WET ETCHING
METHOD USING ULTRAVIOLET LIGHT,
AND METHOD OF MANUFACTURING
SEMICONDUCTOR DEVICE

PRELIMINARY AMENDMENT

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Prior to the examination of the above-identified patent application, please enter the following amendments and consider the following remarks.

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Application No. Unassigned

TITLE AMENDMENTS:

Replace the title with:

ULTRAVIOLET LIGHT RADIATING APPARATUS, WET ETCHING APPARATUS AND
WET ETCHING METHOD USING ULTRAVIOLET LIGHT, AND METHOD OF
MANUFACTURING SEMICONDUCTOR DEVICE